## Notice of References Cited Application/Control No. 10/734,769 Examiner Jack Chiang Applicant(s)/Patent Under Reexamination LEE, GEUN JU Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-2005/0141703	06-2005	Hickey et al.	379/433.13
	В	US-2004/0203517	10-2004	Park et al.	379/433.13
	ပ	US-2003/0068988	04-2003	Janninck et al.	379/433.13
	D	US-6,850,784	02-2005	SanGiovanni, John	379/433.12
	E	US-			
	F	US-			
	G	US-			
	Н	US-			
	ı	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	ο					
	R					
	S	* ***		-		
	Т					

## **NON-PATENT DOCUMENTS**

	NOTE A PRODUCTION							
*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)						
	U							
	V							
	W							
	x							

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.